

## ULTRASONIC PROBE AND METHOD FOR FABRICATING THE PROBE

### CROSS-REFERENCE TO RELATED APPLICATIONS

This application is based upon and claims the  
5 benefit of priority from the prior Japanese Patent  
Application No. 2003-46515, filed February 24, 2003,  
the entire contents of which are incorporated herein by  
reference.

### 10 BACKGROUND OF THE INVENTION

#### 1 Field of the Invention

The present invention relates to an ultrasonic  
probe for sending and receiving an ultrasonic wave and  
a method for fabricating the probe.

#### 15 2 Description of the Related Art

For example, ultrasonic diagnostic equipment has  
been used in medical diagnosis or industrial diagnosis,  
in which a lesion in the body or a crack in piping is  
detected by sending an ultrasonic wave to a diagnostic  
20 object such as the human body or piping and receiving a  
reflected wave of the ultrasonic wave. The ultrasonic  
diagnostic equipment comprises a main body of the  
equipment and an ultrasonic probe for sending and  
receiving the ultrasonic wave.

25 Fig.14 and Fig.15 show a configuration of a  
conventional ultrasonic probe of ultrasonic diagnostic  
equipment for medical application. As shown in Fig.14,

the ultrasonic probe has a piezoelectric transducer 201. The piezoelectric transducer 201 is formed into a rectangular, piezoelectric element by dicing a platelike piezoelectric ceramic.

5           An audio matching layer 203 for matching audio impedance is provided at an earth electrode 201c side of the piezoelectric transducer 201, and in turn an audio lens 205 is provided on a surface of the audio matching layer 203. A backing material 209 comprising  
10           rubber having a good sound absorption performance is jointed to a signal electrode 201b side of the piezoelectric transducer 201 through epoxy based resin 207.

          On both side faces of the piezoelectric transducer  
15           201, flexible printed circuits 211 (FPCs) are disposed such that they are opposed to each other. Each of end portions of the FPCs 211 is connected to the signal electrode 201b or earth electrode 201c of the piezoelectric transducer 201 through a soldering  
20           material.

          As shown in Fig.15, the FPCs 211 are bended at approximately 90 degrees in the vicinity of the connected portion to the piezoelectric transducer 201, and a rear anchor portions of the FPCs are connected to  
25           a main body (not shown) of the ultrasonic diagnostic equipment disposed at a backing material 209 side.

          When the ultrasonic probe having the above

configuration is used, first an audio lens 205 is contacted to a diagnosis object. Then, an electrical signal is applied to the piezoelectric transducer 201 through the FPCs 211, thereby an ultrasonic wave is generated from the piezoelectric transducer 201. The generated ultrasonic wave is sent to the diagnosis object through the audio lens 205, and reflected within the diagnosis object, and then received by the piezoelectric transducer 201. The received ultrasonic wave is converted to an electric signal in the piezoelectric transducer 201, and transferred to the main body of the ultrasonic diagnostic equipment through the FPCs 211.

In such configured ultrasonic probe, the FPCs 211 are bent at approximately 90 degrees in the vicinity of the jointed portion with the piezoelectric transducer 201. According to the finite deflection theory, bending stress exerted on the curved portions of the FPCs 211 exceeds  $100 \text{ N/mm}^2$ , therefore the jointed portions of the FPCs 211 with the piezoelectric transducer 201 were easily broken due to the bending stress exerted on the curved portions of the FPCs 211. Particularly, in dicing, large machining stress is applied to the jointed portions of the FPCs 211 with the piezoelectric transducer 201, therefore the jointed portions were still further easily broken.

Thus, a configuration in which the FPCs are

connected to the piezoelectric transducer without being curved by projecting an end portion of the piezoelectric transducer from an end face of the backing material has been developed. In the ultrasonic probe, the FPCs are arranged along the end face of the backing material, and the end portions of the FPCs are jointed with the earth electrode formed on a bottom of the projected end of the piezoelectric transducer.

However, when the end portion of the piezoelectric transducer is projected from the end face of the backing material, there is a problem that a structure having the projected portion floating in the air is formed, and thus the crack is easily occurred in the piezoelectric material due to the machining stress generated in the dicing. Since the crack in the piezoelectric material has a great influence to the ultrasonic characteristics, in recent years, dicing without damaging the piezoelectric material has been required.

#### BRIEF SUMMARY OF THE INVENTION

The invention, which was made in view of the above circumstances, aims to provide an ultrasonic probe that can restrain breakdown of the piezoelectric material and improve the jointed strength of the piezoelectric transducer with a conductive substrate, and provide a method for fabricating the probe.

To solve the above problems and achieve the objects, the ultrasonic probe and the method for fabricating the probe of the invention are configured as follows.

5           A piezoelectric transducer for sending and receiving the ultrasonic wave and a conductive substrate for applying current to the piezoelectric transducer are provided, the conductive substrate is arranged oppositely to a side face of the piezoelectric  
10 transducer, and a conductive material that electrically connects the piezoelectric transducer to the conductive substrate is arranged in a corner portion formed by the piezoelectric transducer and the conductive substrate.

          Additional objects and advantages of the invention  
15 will be set forth in the description which follows, and in part will be obvious from the description, or may be learned by practice of the invention. The objects and advantages of the invention may be realized and obtained by means of the instrumentalities and  
20 combinations particularly pointed out hereinafter.

#### BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

          The accompanying drawings, which are incorporated in and constitute a part of the specification,  
25 illustrate presently preferred embodiments of the invention, and together with the general description given above and the detailed description of the

preferred embodiments given below, serve to explain the principles of the invention.

Fig.1 is a perspective view showing a configuration of an ultrasonic probe according to the first embodiment of the invention;

Fig.2 is a cross sectional view showing the configuration of the ultrasonic probe according to the embodiment;

Fig.3 is a cross sectional view cut along the line A-A in Fig.2, showing the configuration of the ultrasonic probe according to the embodiment;

Fig.4 is a cross sectional view cut along the line B-B in Fig.2, showing the configuration of the ultrasonic probe according to the embodiment;

Fig.5A to Fig.5C are process views showing a fabrication process of the ultrasonic probe according to the embodiment;

Fig.6A to Fig.6C are process views showing the fabrication process of the ultrasonic probe according to the embodiment;

Fig.7A and Fig.7B are process views showing the fabrication process of the ultrasonic probe according to the embodiment;

Fig.8 is a schematic view showing a pattern of signal and earth wirings before dicing according to the embodiment;

Fig.9 is a cross sectional view showing a

configuration of an ultrasonic probe according to the second embodiment of the invention;

Fig.10 is a graph showing results of a peeling strength evaluation test;

5            Fig.11 is a photograph showing results of a dicing tolerance test, where A is a case when a fillet is formed in a jointed portion and B is a case when the fillet is not formed in the jointed portion;

10           Fig.12 is a cross sectional view showing a configuration of an ultrasonic probe according to the third embodiment of the invention;

Fig.13 is a cross sectional view showing a conventional ultrasonic probe;

15           Fig.14 is a perspective view showing the conventional ultrasonic probe;

and Fig.15 is a cross sectional view showing the conventional ultrasonic probe.

#### DETAILED DESCRIPTION OF THE INVENTION

20           Hereinafter, the first embodiment of the invention is described with reference to Fig.1 to Fig.8. Fig.1 is a perspective view showing a configuration of an ultrasonic probe according to the first embodiment of the invention; Fig.2 is a cross sectional view showing the configuration of the ultrasonic probe according to  
25           the embodiment; Fig.3 is a cross sectional view cut along the line A-A in Fig.2 showing the configuration

of the ultrasonic probe according to the embodiment;  
and Fig.4 is a cross sectional view cut along the line  
B-B in Fig.2.

5       The ultrasonic probe shown in Fig.1 and Fig.2 has  
a piezoelectric transducer 1. The piezoelectric  
transducer 1 has a rectangular solid shape, and  
respective three edges of the shape are corresponding  
to the three directions of x, y, and z which are  
perpendicular to each other.

10       As shown in Fig.3, the piezoelectric transducer 1  
comprises a large number of (for example, 128 to 256),  
strip-shaped piezoelectric elements 2 arranged with a  
predetermined interval along the X direction (only  
eleven elements are shown).

15       Each of the piezoelectric elements 2 has a  
piezoelectric material 2a, an earth electrode 2c (first  
electrode), and a signal electrode 2b (second  
electrode), and each of the signal electrode 2b and  
earth electrode 2c is provided on either end of the  
20       piezoelectric material 2a in the z direction. On a  
surface of the earth electrode 2c, an audio matching  
layer 3 for matching audio impedance is provided.

25       As a material for the piezoelectric material 2a,  
ceramics of lead zirconate titanate (PZT), PZNT single  
crystal comprising solid solution of lead zinc-niobate  
and lead titanate, or PZMT single crystal comprising  
solid solution of lead magnesium-niobate and lead



titanate is used. As a material for the signal electrode 2b and earth electrode 2c, a good conductor such as gold or silver is used. As a material for the audio matching layer 3, glass or resin is used.

5           As shown in Fig.1 and Fig.2, at an earth electrode 2c side of the piezoelectric transducer 1, an audio lens 4 is provided through the audio matching layer 3. At a signal electrode 2b side of the piezoelectric transducer 1, a block-like backing material 5 is  
10           jointed through epoxy-based resin 14. As a material for the backing material 5, the rubber having the good sound absorption performance is used.

          On one side face of the piezoelectric transducer 1 in the y direction, an FPC 6 (conductive substrate) is  
15           provided substantially perpendicular to the y direction, or provided such that composition angle,  $\theta$ , is approximately 90 degrees. The FPC 6 has a signal wiring 6b and an earth wiring 6c insulated from each other through an insulating layer 6a, and an outside of  
20           the FPC is covered by a cover material 6d made of an insulating material. Each of the wirings 6b and 6c has electrical paths 7 of which the number is corresponding to number of the above piezoelectric elements 2 (refer to Fig.4).

25           End portions of the electrical paths 7 of respective wirings 6b, 6c are exposed from the cover material 6d of the FPC 6 to a piezoelectric transducer

1 side as a signal wiring electrode 8b and an earth  
wiring electrode 8c. Interval between the signal  
wiring electrode 8b and earth wiring electrode 8c is  
approximately equal to the size of the piezoelectric  
5 transducer 1 in the z direction, and each of the signal  
wiring electrode 8b and the earth wiring electrode 8c  
is positioned at either side of the piezoelectric  
transducer 1 in the y direction.

A soldering material 9 (conductive material) is  
10 arranged in corner portions 10a, 10b formed by the  
piezoelectric transducer 1 and the FPC 6. The  
soldering material 9 at the first corner 10a positioned  
at the earth electrode 2c side electrically connects  
the earth wiring electrode 8c to the earth electrode  
15 2c, and the soldering material 9 at the second corner  
10b positioned at the signal electrode 2b side  
electrically connects the signal wiring electrode 8b to  
the signal electrode 2b.

A fillet is formed in the peripheral region of a  
20 soldering material 12. The fillet generates a tensile  
stress, which is stronger than a sharing stress, on a  
jointed surface with the piezoelectric transducer 1 or  
FPC 6, and thus improves jointing strength on the  
jointed surface. The soldering material 12 is coated  
25 by a nonconductive resin material 13 (nonconductive  
material) in order to protect the surface of the  
material 9.

Nonconductive adhesive 11 (nonconductive material) for insulating the signal electrode 2b from the earth electrode 2c is interposed between the piezoelectric transducer 1 and FPC 6. The nonconductive adhesive 11  
5 acts to temporarily fix the piezoelectric transducer 1 to the FPC 6 in fabrication process of the ultrasonic probe as described later.

A rear anchor portion of the FPC 6 is connected to a main body of ultrasonic diagnostic equipment (not  
10 shown) disposed at a backing material 5 side through a connector (not shown).

When the configured ultrasonic probe is used, first the audio lens 4 is contacted to a diagnosis object. Then, an electric signal is applied from the  
15 main body of the ultrasonic diagnostic equipment to the piezoelectric transducer 1 through the signal wiring 6b and the earth wiring 6c, so that an ultrasonic wave is generated from the piezoelectric transducer 1. The generated ultrasonic wave is sent to the diagnosis  
20 object through the audio lens 4, and reflected within the diagnosis object, and then received by the piezoelectric transducer 1. The received ultrasonic wave is converted to an electric signal by the piezoelectric transducer 1, and then transferred to the  
25 main body of the ultrasonic diagnostic equipment through the signal wiring 6b and the earth wiring 6c.

Next, a method for fabricating the configured

ultrasonic probe is described using Fig.5 to Fig.7.

As shown in Fig.5A, a piezoelectric transducer before being separated 21 is prepared. The piezoelectric transducer before being separated 21 has a rectangular-solid-like piezoelectric material 21a. The three edges of the piezoelectric material 21a are in correspondence with the x, y, and z directions, and metallic thin films 21b, 21c such as gold or silver film are formed on both faces in the z direction.

Next, as shown in Fig.5B, the FPC 6 is disposed approximately perpendicular to the y direction on one side face of the piezoelectric transducer before being separated 21 in the y direction, and then the piezoelectric transducer before being separated 21 is temporarily fixed to the FPC 6 by the nonconductive adhesive 11.

Next, as shown in Fig.5C, the soldering material 9 is supplied to the corner portion 10 formed by the piezoelectric transducer before being separated 21 and the FPC 6, and the metallic thin film 21b is welded to the signal wiring electrode 8b using a contact type heat tool (heating unit) such as a soldering iron, as well as the metallic thin film 21c is welded to the earth wiring electrode 8c.

Thereby, the metallic thin film 21b is electrically connected to the signal wiring electrode 8b, as well as the metallic thin film 21c is

electrically connected to the earth wiring electrode 8c. In this condition, the signal wiring electrode 8b and the earth wiring electrode 8c are electrically communicated through a flat portion 22 (refer to Fig.8).

For heating the soldering material 9, a noncontact type heater tool including laser irradiation or infrared ray irradiation can be used in addition to the contact type heat tool such as the soldering iron.

Also, soldering cream or conductive adhesive can be used instead of the soldering material 9. When the soldering cream is used, atmosphere heating is generally carried out; however, if the heating temperature is not less than Curie point of the piezoelectric material 21a, depolarization occurs in the piezoelectric material 21a, therefore repolarization treatment needs to be performed in subsequent processes. When the conductive adhesive is used, hardening by atmosphere heating as in the soldering cream or photo-reactive hardening by ultraviolet ray irradiation is performed.

Next, as shown in Fig.6A, the surface of the soldering material 9 is coated by the nonconductive resin material 13 in order to prevent the jointed portions 12 of the signal electrode 2b with the signal wiring electrode 8b and the earth electrode with the earth wiring electrode 8c.

Next, as shown in Fig.6B, the audio matching layer 3 is jointed with the surface of the metallic thin film 21c, and then the block-like backing material 5 is jointed with the surface of the metallic thin film 21b through the epoxy-based resin 14.

Through the above processes, a layer structure 23 comprising the audio matching layer 3, metallic thin film 21c, piezoelectric material 21a, metallic thin film 21b, and backing material 5 is formed.

Next, as shown in Fig.6C, a large number of grooves 24 are provided in the layer structure 23 using a dicing machine (dicing). The groove portions 24 are formed such that they extend from the audio matching layer 3 side to the backing material 5.

Thereby, the piezoelectric transducer before being separated 21 comprising the piezoelectric material 21a and the metallic thin films 21b, 21c are formed into the above piezoelectric transducer 1 comprising a large number of strip-shaped piezoelectric elements 2 as shown in Fig.7A.

At that time, the flat end portion 22 of the FPC 6 connected to the metallic thin films 21b, 21c is also cut and divided by the dicing machine, thereby respective piezoelectric elements 2 are electrically communicated to respective electric paths 7 independently.

Finally, as shown in Fig.7B, the audio lens 4 is

provided on the surface of the audio matching layer 3.  
That is the end of the fabrication process of the  
ultrasonic probe.

According to the above configured ultrasonic probe  
5 and the method for fabricating the probe, the FPC 6 is  
disposed substantially perpendicular to the y direction  
on one side face of the piezoelectric transducer 1 in  
the y direction, and the corner portion 10 formed by  
the piezoelectric transducer 1 and the FPC 6 is  
10 supplied with the soldering material 9, thereby the  
signal electrode 2b is electrically connected to the  
signal wiring electrode 8b, as well as the earth  
electrode 2c is electrically connected to the earth  
wiring electrode 8c.

15 Therefore, since the piezoelectric transducer 1  
can be connected to the FPC 6 without necessity of  
bending the FPC 6, and the connected portion 12 is not  
applied with the unnecessary load, the jointed strength  
of the piezoelectric transducer 1 with the FPC 6 is  
20 improved.

Since the corner portion 10 formed by the  
piezoelectric transducer 1 and the FPC 6 has an angle  
of approximately 90 degrees, the fillet is easily  
formed by the soldering material 9 supplied to the  
25 corner portion 10. Since the fillet improves breaking  
tolerance on a jointed face with the piezoelectric  
transducer 1 or the FPC 6, the jointing strength of the

piezoelectric transducer 1 with the FPC 6 can be improved.

Furthermore, as described above, since the jointed strength of the piezoelectric transducer 1 with the FPC 6 is improved, damage to the jointed portion 12 due to the machining stress exerted on the jointed portion 12 in the dicing can be restrained.

The FPC 6 having the signal wiring 8b and the earth wiring 8c is also used as the conductive substrate.

Thus, since electrical current can be applied to the piezoelectric transducer 1 using only one FPC 6, the component cost can be reduced.

Furthermore, the nonconductive adhesive 11 is interposed between the piezoelectric transducer 1 and FPC 6.

Thus, since the signal side and earth side of the piezoelectric transducer 1 are isolated from each other by the nonconductive adhesive 11, operation of supplying the soldering material 9 to the corner portion 10 formed by the piezoelectric transducer 1 and the FPC 6 can be easily carried out.

The soldering material 9 supplied to the corner portion 10 is coated by the nonconductive resin material 13 in order to protect the material 9 from the ambient air or moisture.

Thus, since the soldering material 9 becomes hard



to deteriorate, reduction of the jointed strength of the piezoelectric transducer 1 with the FPC 6 can be suppressed.

5 Next, the second embodiment of the invention is described with reference to Fig.9.

Fig.9 is a cross sectional view showing a configuration of the ultrasonic probe according to the second embodiment of the invention. In a description of the embodiment, the same components as in the first  
10 embodiment are marked with the same symbols and explanation for the components is omitted.

As shown in Fig.9, in the ultrasonic probe according to the embodiment, FPCs 31b, 31c are provided on both sides of the piezoelectric transducer 1 in the  
15 y direction respectively. Each of the FPCs 31b, 31c has a signal wiring 32b and an earth wiring 32c, and each of the signal wiring 32b and the earth wiring 32c has electric paths 7 of which the number is corresponding to the number of the piezoelectric  
20 elements 2.

Respective end portions of the FPCs 31b, 31c are bended at a bending angle,  $\phi$ , to the piezoelectric transducer 1 side, and corner portions 33 of which the composition angle is  $\theta$  are formed between the  
25 piezoelectric transducer 1 and the FPCs 32b, 32c. Although the composition angle,  $\theta$ , can be within a range from 5 degrees to 90 degrees, preferably, it is

10 degrees to 90 degrees.

The soldering material 9 is supplied to the corner portions 33 formed by the piezoelectric transducer 1 and the FPCs 31b, 31c. The soldering material 9  
5 electrically connects the earth electrode 2c to the earth wiring 32c, and the signal electrode 2b to the signal wiring 32b.

In the configured ultrasonic probe, the FPCs 31b, 31c for applying current to the piezoelectric  
10 transducer 1 are disposed at both sides of the piezoelectric transducer 1 in the y direction, and end portions of the FPCs that are connected to the piezoelectric transducer 1 are bended to the piezoelectric transducer 1 side.

15 Thus, since bending stress exerted on curved portions of the FPCs 31b, 31c can be made small, load applied to the jointed portions of the piezoelectric transducer 1 with the FPCs 31b, 31c is reduced. Thereby, jointed strength of the piezoelectric  
20 transducer 1 with the FPCs 31b, 31c is improved.

Furthermore, since the composition angle,  $\theta$ , of the corner portions 33 is made to be 5 degrees or more, the fillet is easily formed by the supplied soldering material 9.

25 Thus, according to the same principle as in the first embodiment, the jointed strength of the piezoelectric transducer 1 with the FPCs 31b, 31c is

improved.

Next, a peeling strength evaluation test and a dicing tolerance test are described. The peeling strength evaluation test and the dicing tolerance test are conducted to clear effects of the fillet on the jointed strength of the piezoelectric transducer 1 with the FPC 6.

Fig.10 shows results of the peeling strength evaluation test. In Fig.10, points P indicate the average peeling load, and upper and lower ends of lines extending vertically from the points P indicate the maximum and minimum values of the peeling load respectively.

In the peeling strength evaluation test, the peeling load required for peeling the FPC that is jointed by soldering with a piezoelectric transducer from the piezoelectric transducer was measured. Test pieces with and without the fillet formed in the jointed portion 12 of the piezoelectric transducer 1 with the FPC were prepared ten pieces each.

The test conditions are as follows:  
width of the test piece: approximately 2 mm;  
number of tests: 10;  
composition angle of the corner portion  $\theta$ : 5 degrees.

As shown in Fig.10, the average peeling load in the case without forming the fillet in the jointed

portion was 0.44 N. On the other hand, the average peeling load in the case with forming the fillet in the jointed portion was 1.74 N. That is, it was found that the average peeling load in the case with forming the fillet was improved to almost quadruple of that in the case without forming the fillet.

Accordingly, it was confirmed from the peeling strength evaluation test that the jointed strength of the piezoelectric transducer with the FPC was drastically improved by forming the fillet in the jointed portion in jointing the piezoelectric transducer with the FPC.

The inventors still conducted the peeling strength evaluation test in the case that the composition angle,  $\theta$ , was 10 degrees and confirmed that further large effects were obtained.

Fig.11A and 11B show results of the dicing tolerance test.

In the dicing tolerance test, element width was measured when the FPC jointed by soldering with the piezoelectric transducer was peeled from the piezoelectric transducer with cutting pitch being narrowed by 1 mm every sixth dicing. Test pieces with and without the fillet formed in the jointed portion of the piezoelectric transducer with the FPC were prepared respectively.

The test conditions are as follows:

rotational frequency of blade: 30000 rpm;

blade width: 0.05 mm;

cutting pitch: 0.15 mm to 0.10 mm;

element width: 0.1 mm to 0.05 mm.

5           As shown in Fig.11A, 11B, when the fillet was not formed in the jointed portion, peeling was occurred at an element width of 0.07 mm. On the other hand, when the fillet was formed in the jointed portion, peeling was not found even at an element width of 0.05 mm.

10           Accordingly, it was confirmed that when the piezoelectric transducer was jointed with the FPC in the dicing tolerance test, the peeling of the FPC from the piezoelectric transducer due to the machining stress applied in dicing was restrained by forming the  
15           fillet in the jointed portion.

          The inventors still conducted the dicing tolerance test in the case that the composition angle,  $\theta$ , was 10 degrees and confirmed that further large effects were obtained.

20           Next, numerical comparison of the bending stress exerted on the FPC to that in the related art is described. In this numerical comparison, an FPC having a stacked structure of polyimide/Cu/polyimide was used.

          The calculation conditions (related art) are as  
25           follows:

          radius of curvature,  $R$ , of FPC: 5 mm;

          bending angle,  $\phi$ : 90 degrees;

thickness of Cu,  $t$ : 0.025 mm;

and Young's modulus,  $E$ , of Cu: 130000 N/mm<sup>2</sup>.

The maximum value of the bending stress,  $\sigma$ ,  
exerted on the curved portion is expressed with the  
5 following numerical formula 1 according to the  
functional relation between stress and strain.

(The numerical formula 1 is inserted here.)

10 As shown in the numerical formula 1, when the FPC  
is bended at the above conditions, the maximum value of  
the bending stress,  $\sigma$ , exerted on the curved portion is  
approximately 325 N/mm<sup>2</sup>.

On the other hand, in the ultrasonic probe  
15 according to the first embodiment, it is found that the  
bending stress is zero because of the structure where  
the FPC is not bended, and the bending stress is  
drastically decreased compared with the related art.

Also, in the ultrasonic probe according to the  
20 second embodiment, it is found that the bending stress  
is decreased compared with the related art because the  
bending angle,  $\phi$ , is less than 90 degrees.

Fig.12 is a cross sectional view showing a  
configuration of the ultrasonic probe according to the  
25 third embodiment of the invention. The ultrasonic  
probe shown in Fig.12 has a piezoelectric transducer  
101. The piezoelectric transducer 101 has a

rectangular solid shape. The piezoelectric transducer 101 comprises a large number of (for example, 128 to 256) strip-shaped piezoelectric elements 102.

Each of the piezoelectric elements 102 has a  
5 piezoelectric material 102a, earth electrode 102c  
(first electrode), and signal electrode 102b (second  
electrode), and each of the signal electrode 102b and  
the earth electrode 102c is provided on either end face  
of the piezoelectric material 102a in a radial  
10 direction. On a surface of the earth electrode 102c,  
the audio matching layer 103 for matching the audio  
impedance is provided.

The same materials as those for the piezoelectric  
material 2a, signal electrode 2b and earth electrode  
15 2c, and audio matching layer 3 are used for the  
piezoelectric material 102a, signal electrode 102b and  
earth electrode 102c, and audio matching layer 103.

As shown in Fig.1 and Fig.2, at the earth  
electrode 102c side of the piezoelectric transducer  
20 101, an audio lens 104 is provided through the audio  
matching layer 103. At the signal electrode 102b side  
of the piezoelectric transducer 101, a block-like  
backing material 105 is jointed through epoxy-based  
resin 114. A material such as the rubber having the  
25 good sound absorption performance is used for the  
backing material 105.

An FPC 106 (first conductive substrate) is

provided parallel on one side face of the piezoelectric transducer 101 with a slight interval, or provided such that the composition angle,  $\theta$ , is approximately 90 degrees, and an FPC 107 (second conductive substrate) is provided parallel on the other side face with a slight interval, or provided such that the composition angle,  $\theta$ , is approximately 90 degrees.

The FPC 106 has a signal wiring 106a exposed to the piezoelectric transducer 101 side. The signal wiring 106a has electrical paths (refer to Fig.4) of which the number is corresponding to the number of the piezoelectric elements 102. The FPC 107 has an earth wiring 107a exposed to the piezoelectric transducer 101 side. The earth wiring 107a has the electrical paths (refer to Fig.4) of which the number is corresponding to the number of the piezoelectric elements 102.

In a corner portion 110a formed by the piezoelectric transducer 101 and the FPC 107, fillet 109a formed by a soldering material (conductive material) is arranged. The soldering material 109 in the first corner portion 110a positioned at the earth electrode 102c side electrically connects the earth wiring 107a to the earth electrode 102c.

A fillet 109b formed by the soldering material is arranged in a corner portion 110b formed by the piezoelectric transducer 101 and the FPC 106. The fillet 109b in the second corner portion 110b



positioned at the signal electrode 102b side  
electrically connects the signal wiring 106a to the  
signal electrode 102b.

5       The fillets 109a, 109b generate a tensile stress  
that is stronger than a shearing stress on the jointed  
faces with the piezoelectric transducer 101 or the FPCs  
106, 107, and thus improve the jointing strength on the  
jointed faces. The fillets 109a, 109b are coated by  
the nonconductive resin material 113 (nonconductive  
10       material) in order to protect their surfaces.

      A nonconductive adhesive 111 (nonconductive  
material) for insulating the signal electrode 102b from  
the earth electrode 102c is interposed between the  
piezoelectric transducer 101 and the FPC 106. The  
15       nonconductive adhesive 111 also acts to temporarily fix  
the piezoelectric transducer 101 to the FPCs 106, 107  
in the fabrication process of the ultrasonic probe.

      Rear anchor portions of the FPCs 106, 107 are  
connected to the main body of the ultrasonic diagnostic  
20       equipment (not shown) disposed at the backing material  
105 side through the connector (not shown).

      In the configured ultrasonic probe, the FPCs 106,  
107 are disposed parallel on the side faces of the  
piezoelectric transducer 101, and the fillets 109a,  
25       109b are formed in the corner portions 110a, 110b  
formed by the piezoelectric transducer 101 and the FPCs  
106, 107, thereby the signal electrode 102b is

connected electrically to the signal wiring 106a, and the earth electrode 102c is connected to the earth wiring 107a.

Thus, since the FPCs 106, 107 can be maintained flat without requiring bending the FPCs 106, 107 in the vicinity of the piezoelectric transducer 101 to connect the piezoelectric transducer 101 to the FPCs 106, 107, the unnecessary load is not applied, therefore the jointed strength of the piezoelectric transducer 101 with the FPCs 106, 107 is improved.

Fig.13 is a view showing a related art for illustrating the jointed strength in Fig.12, and a same symbol is marked to a same functional part as in Fig.12, and detailed description of the art is omitted.

While soldering strength is 0.22 N/mm in the art shown in Fig.13, the strength is 1.62 N/mm in the embodiment shown in Fig.12, which shows improvement of the soldering strength. Also, while the bending stress of the FPC is 300 N/mm<sup>2</sup> in the art shown in Fig.13, it is approximately 0 N/mm<sup>2</sup> in the embodiment shown in Fig.12, which shows substantially no load is applied.

The invention, which is not limited to the above embodiments, can be altered variously within a scope without going beyond the gist of the invention.

Additional advantages and modifications will readily occur to those skilled in the art. Therefore, the invention in its broader aspects is not limited the

specific details and representative embodiments shown  
and described herein. Accordingly, various  
modifications may be made without departing from the  
spirit or scope of the general inventive concept as  
5 defined by the appended claims and their equivalents.